



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

APPLICATION NUMBER	FILING/RECEIPT DATE	FIRST NAMED APPLICANT	ATTORNEY DOCKET NUMBER
09/809,663	03/15/2001	Mukesh V. Khare	FIS920000396US1

CONFIRMATION NO. 5741

FORMALITIES LETTER



OC000000006093263

Sean F. Sullivan
Cantor Colburn LLP
55 Griffin Road South
Bloomfield, CT 06002

Date Mailed: 05/18/2001

NOTICE TO FILE CORRECTED APPLICATION PAPERS

Filing Date Granted

This application has been accorded an Application Number and Filing Date. The application, however, is informal since it does not comply with the regulations for the reason(s) indicated below. Applicant is given **TWO MONTHS** from the date of this Notice within which to correct the informalities indicated below. Extensions of time may be obtained by filing a petition accompanied by the extension fee under the provisions of 37 CFR 1.136(a)

The required item(s) identified below must be timely submitted to avoid abandonment:

- Substitute drawings in compliance with 37 CFR 1.84 because:
 - drawing sheets do not have the appropriate margin(s) (see 37 CFR 1.84(g)). Each sheet must include a top margin of at least 2.5 cm. (1 inch), a left side margin of at least 2.5 cm. (1 inch), a right side margin of at least 1.5 cm. (5/8 inch), and a bottom margin of at least 1.0 cm. (3/8 inch);

*A copy of this notice **MUST** be returned with the reply.*

A. T.
Customer Service Center

Initial Patent Examination Division (703) 308-1202

PART 2 - COPY TO BE RETURNED WITH RESPONSE

H-A

0300

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): **KHARE ET AL.**

Docket No.

FIS920000396US1 / I30-0001

Serial No.

Filing Date

Examiner

Group Art Unit

09/809,663

3/15/2001

NYA

2811

Invention: **METHOD FOR IMPROVED PLASMA NITRIDATION OF ULTRA THIN GATE DIELECTRICS**

I hereby certify that this **Response to Notice to File Corrected Application Papers**

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

May 25, 2001

(Date)

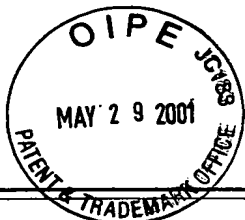
Jessica L. Walsh

(Typed or Printed Name of Person Mailing Correspondence)

Jessica L. Walsh

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.



4

TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
FIS920000396US1 / I30-0001

In Re Application Of: **Mukesh Khare et al.**

Serial No.	Filing Date	Batch No.	Examiner	Art Unit
09/809,663	3/15/2001			

Invention:

METHOD FOR IMPROVED PLASMA NITRIDATION OF ULTRA THIN GATE DIELECTRICS

Address to:
Assistant Commissioner for Patents
Washington, D.C. 20231

Transmitted herewith are:

9 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c) on the reverse side of the drawing.

Signature

Sean F. Sullivan
Reg. No. 38,328
Cantor Colburn LLP
55 Griffin Road South
Bloomfield, CT 06002
(860) 286-2929
Customer Service # 23413

Dated: April 3, 2001

I certify that this document and attached formal drawings are being deposited on 4/3/2001 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Jessica L. Walsh

Typed or Printed Name of Person Mailing Correspondence